

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit:

In re application of:

Hiroyuki Kinoshita et al.

Serial No: 08/808,315

Filed: February 27, 1997

For: Sapphire Monocrystal, Semiconductor

Laser Diode Using the Same for

Substrate, and Method for Manufacturing the Same

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents Washington, D.C. 20231 Dear Sir:

I hereby certify that this correspondence is being deposited with the

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Examiner: Yoni Y. Chang

sufficient postage as first class mail in an envelope addressed to:
Assistant Commissioner for Patents

United States Postal Service with

Washington D.C. 20231, on September 23, 1999 Date of Deposit

John P. Scherlacher

Signature Date

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a 1-month extension of time extending to October 4, 1999, the period for response to the Office Action dated June 4, 1999. A check for \$110 is enclosed. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 12-1820. A copy of this petition is enclosed.

Respectfully submitted,

LOEB & LOEB LLP

Date: September 23, 1999

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